

GSA Gas Purifiers

**N₂, O₂, Ar, CH₄, CO, CO₂...Various gas separation
Purification equipment**

Global Standard Air & Gas



Diverse Gas Purification Systems



High-purity Gas and Ultra High-purity Gas

High-purity gases are used in diverse fields such as semiconductor, petrochemicals, metal engineering, experiments and researches. In particular, it is critical to maintain the properties and quality of high-purity gases in semiconductor, display and other productions.

Regular industrial gases may have some impurities. In addition, they could be contaminated during transport or storage.



Why High-purity Purification System?

A high-purity purification system is needed in various fields where high-purity gases are demanding to provide high-purity gases by purifying low-purity gases.

If high-purity gases are continuously used, it is able to recover initial acquisition costs fast without issues such as short supply and delayed delivery, showing decent economic efficiency.

Features

- **Expertise in gas purification systems**
Optimum PSA and system design according to customer needs
- **Highest quality**
Supplies high-purity gases in a stable fashion based on long design experiences
- **High reliability**
Keeps the product highly reliable with the use of proven, high-quality components
- **Great flexibility**
A highly flexible system which meets diverse gas supply conditions
- **Rational design**
All systems including pipelines pre-assembled and tested before release; time and money for trial run minimized
- **Easy maintenance**
Easy access and management through convenient daily routines



Diverse Gas Purification Systems

N₂ Purifier

Supplies high-purity nitrogen whose impurity concentration (10ppm or above) is reduced to 10ppb or below by eliminating oxygen, CO₂ and others, using a desiccant

- High-pressure nitrogen purification system
- Low-pressure nitrogen purification system



O₂ Purifier

Supplies high-purity oxygen whose impurity concentration (10ppm or above) is reduced to 10ppb or below by eliminating CO, CO₂ and others, using PD catalyst and desiccant

- High-pressure oxygen purification system
- Low-pressure oxygen purification system



CH₄ Purifier

A purification system designed to use CH₄ by eliminating a large amount of impurities in natural gases such as nitrogen and carbon dioxide



Ar Purifier

Supplies high-purity argon whose impurity concentration (10ppm or above) is reduced to 10ppb or below by eliminating N₂, O₂, CO₂, CO and others, using PD catalyst and desiccant

- High-pressure argon purification system
- Low-pressure argon purification system



H₂ Purifier

Supplies high-purity hydrogen whose impurity concentration (10ppm or above) is reduced to 10ppb or below, using a desiccant and heated getter

- Heated getter-based hydrogen purification system
- Liquefied nitrogen-based hydrogen low-temperature purification system



Helium Low-temperature Purifier

Supplies high-purity helium whose impurity concentration (10ppm or above) is reduced to 10ppb or below, using liquefied nitrogen



Argon Recovery & Purification System

Supplies argon by removing nitrogen, oxygen, moisture and others, using a desiccant



High-purity O₂ PSA and Ar PSA System

Divides oxygen from the oxygen generator into high-purity oxygen and argon and supplies

Separates and supplies high-purity oxygen by vacuum-removing and separating the oxygen adsorbed by CMS

A system designed to supply argon after separating nitrogen, using ZMS



CO₂ Removal System

A system designed to eliminate CO₂ in the compressed air



CO₂ Purification and Liquefying System

Carbon dioxide produced by various causes such as rising demand for energy used in diverse fields even though it accounts for 80% of greenhouse gas

The CO₂ purification and liquefying system is a system designed to remove impurities from the collected carbon dioxide and liquefying them



Components

